

2878
3/Suppl. IDS
10/11/00
S. Royall

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)

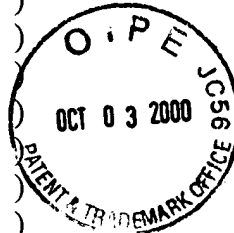
HAIMING WANG ET AL.)

Serial No.: 09/405,716)

Filed: September 24, 1999)

For: SYSTEM FOR ANALYZING)
SURFACE CHARACTERISTICS)
WITH SELF-CALIBRATING)
CAPABILITY)

Group Art Unit: 2878



San Francisco, California

Assistant Commissioner for Patents
Washington, D.C. 20231

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on September 26, 2000.

Tammy L. Kaplan

Signature

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Date

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SUPPLEMENTAL DISCLOSURE STATEMENT

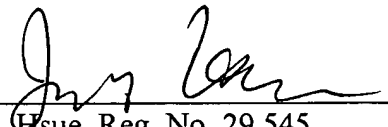
Sir:

The following Form 1449 and copies of documents listed thereon are being filed herewith as a Disclosure Statement. Consideration of each of these documents by the Patent Examiner, and the making of each of them of record in the file of this application, are respectfully requested.

Each item of information contained in this Supplemental Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Respectfully submitted,

Dated: September 26th, 2000



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Atty. Docket: TNCR.170US1